



PATENT

#8/B
Lester
4/1/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Syed Sajid Ahmad

Serial No.: 09/943,967

Filed: August 30, 2001

For: APPARATUS AND METHOD FOR
CONTROLLING THE DEPTH OF
IMMERSION OF A SEMICONDUCTOR
ELEMENT IN AN EXPOSED SURFACE
OF A VISCOUS FLUID

Confirmation No.: 2663

Examiner: M. Trinh

Group Art Unit: 2822

Attorney Docket No.: 3428.2US (97-828.2)

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, Washington, D.C. 20231.

March 17, 2003
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Leah Barrow
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AMENDMENT

Commissioner for Patents
Washington, D.C. 20231

Sir:

The following amendments and remarks are filed in response to the Examiner's remarks in the Office Action mailed December 18, 2002, the three-month shortened statutory period for response to which expires on March 18, 2003.